



IPW

DOCKET: FIS9-2003-0423-US1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR:	Christopher P. Ausschnitt) EXAMINER:
)
SERIAL NO.:	10/771,684) ART UNIT: 2121
)
FILING DATE:	February 3, 2004) DATE: May 11, 2004
)
FOR:	Method of Patterning Process)
	Metrology Based on the Intrinsic)
	Focus Offset)

REQUEST FOR CORRECTION OF FILING RECEIPT

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Dear Sir:

We are in receipt of a Filing Receipt for the above identified application which contains an error.

TITLE

In the title please delete -- intrinis -- and substitute therefor -- intrinsic --.

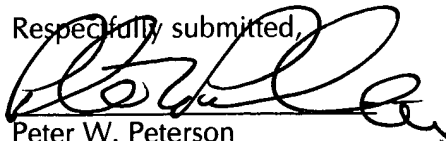
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DeLIO & PETERSON, LLC
121 Whitney Avenue
New Haven, CT 06510-1241
(203) 787-0595

Respectfully submitted,


Peter W. Peterson
Reg. No. 31,867

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I hereby certify that this correspondence is being deposited with the United States Postal Service on the date indicated below as first class mail in an envelope addressed to Mail Stop _____, Commissioner for Patents, P.O. 1450, Alexandria, VA 22313-1450.

Name: Marsha Speranza Date: May 11, 2004 Signature: Marsha H. Speranza



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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/771,684	02/03/2004	2121	770	FIS920030423US1	7	20	2

29505
 DELIO & PETERSON, LLC
 121 WHITNEY AVENUE
 NEW HAVEN, CT 06510

CONFIRMATION NO. 4817

FILING RECEIPT



OC000000012535317

FILE F-421
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Date Mailed: 05/05/2004

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Applicant(s)

Christopher P. Ausschnitt, Lexington, MA; ✓

Assignment For Published Patent Application

International Business Machines Corporation, Amonk, NY;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 05/05/2004

Projected Publication Date: 08/04/2005

Non-Publication Request: No

Early Publication Request: No

Title

Method of patterning process metrology based on the intrinsic focus offset

Preliminary Class

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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